



Attorney's Docket No.: 14072-010001 / W 555

1614  
RECEIVED  
APR 04 2003  
TECH CENTER 1600/2900

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Burrell et al  
Serial No. : 09/840,637  
Filed : April 23, 2001  
Title : TREATMENT OF ACNE

Art Unit : 1614  
Examiner : J. Pak

Commissioner for Patents  
Washington, D.C. 20231

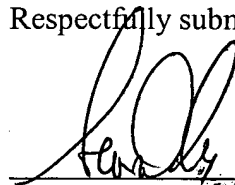
INFORMATION DISCLOSURE STATEMENT

Copies of the references listed on the attached form PTO-1449 are enclosed.

This statement is being filed after a first Office action on the merits, but before receipt of a final Office action or a Notice of Allowance. A check for \$180 in payment of the late submission fee of §1.17(p) is enclosed. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 3/27/03

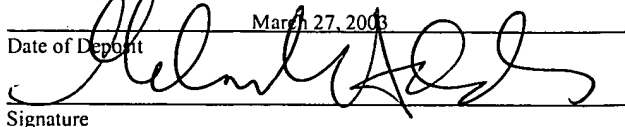
  
Sean P. Daley  
Reg. No. 40,978

Fish & Richardson P.C.  
225 Franklin Street  
Boston, Massachusetts 02110-2804  
Telephone: (617) 542-5070  
Facsimile: (617) 542-8906

20650116.doc

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

Date of Deposit March 27, 2003  
  
Signature

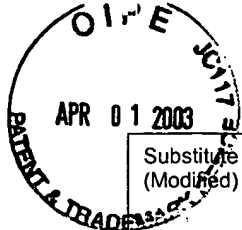
Melissa K. Addis

Typed or Printed Name of Person Signing Certificate

04/03/2003 HBLANCO 00000023 09840637

01 FC:1806

180.00 DP



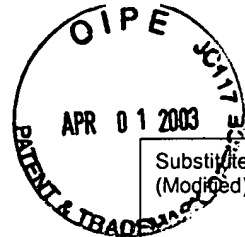
Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 14072-010001	Application No. 09/840,637
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))		Applicant Burrell et al	
		Filing Date April 23, 2001	Group Art Unit 1614

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2002/0192298 A1	12/19/02	Burrell et al.			
	AB	2002/0051824 A1	05/02/02	Burrell et al.			
	AC	6,333,093	12/25/01	Burrell et al.			
	AD	6,238,686	05/29/01	Burrell et al.			
	AE	6,017,553	01/25/00	Burrell et al.			
	AF	5,985,308	11/16/99	Burrell et al.			
	AG	5,958,440	09/28/99	Burrell et al.			
	AH	5,848,995	12/15/98	Walder			
	AI	5,837,275	11/17/98	Burrell et al.			
	AJ	5,770,258	06/23/98	Takizawa			
	AK	5,753,251	05/19/98	Burrell et al.			
	AL	5,681,575	10/28/97	Burrell et al.			
	AM	5,454,886	10/03/95	Burrell et al.			

RECEIVED  
APR 04 2003  
TECH CENTER 1600/2900

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AN	02/09729	02/07/02	WIPO				
	AO	01/80920	11/01/01	WIPO				
	AP	01/68179 A1	09/20/01	WIPO				
	AQ	01/49301	07/12/01	WIPO				
	AR	2000327578	11/28/00	JP (full document)				X
	AS	2000327578	11/28/00	JP (abstract only)			X	
	AT	00/27390	05/18/00	WIPO				
	AU	0 328 421 A2	08/16/99	EP				
	AV	11124335	05/11/99	JP (full document)				X
	AW	11124335	05/11/99	JP (abstract only)			X	
	AX	11116488	04/27/99	JP (full document)				X

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	



Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 14072-010001	Application No. 09/840,637
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))		Applicant Burrell et al	
		Filing Date April 23, 2001	Group Art Unit 1614

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AY	11116488	04/27/99	JP (abstract only)			X	
	AZ	11060493	03/02/99	JP (full document)				X
	AAA	11060493	03/02/99	JP (abstract only)			X	
	ABB	98/41095	09/24/98	WIPO				
	ACC	0681841	11/15/95	EP				
	ADD	95/13704	05/26/95	WIPO				
	AEE	93/23092	11/25/93	WIPO				

RECEIVED  
APR 04 2003  
TECH CENTER 1600/2900

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AFF	Sant et al., "Morphology of Novel Antimicrobial Silver Films Deposited By Magnetron Sputtering" <i>Scripta Materiala</i> , Vol. 41, No. 12, pp. 1333-1339, November 19, 1999

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	